

10/574835

IDS Dated 4/6/2006

APPROPRIATE PTO OFFICE  
06 APR 2006

|   |                  |                 |
|---|------------------|-----------------|
| FORM PTO-1449<br><br>U.S. DEPARTMENT OF COMMERCE<br>PATENT AND TRADEMARK OFFICE<br><br>LIST OF REFERENCES CITED BY APPLICANT<br><br>(Use several sheets if necessary) | ATTY. DOCKET NO. | SERIAL NO.      |
|   | 60562.00009      | New Application |
|   | APPLICANT        |                 |
|   | SAKAI et al      |                 |
|   | FILING DATE      | GROUP           |
|   | April 6, 2006    | Art Unit 2811   |

## U.S. PATENT DOCUMENTS

| EXAMINER<br>INITIAL |    | DOCUMENT<br>NO. | DATE     | NAME           | CLASS | SUB-<br>CLASS | FILING<br>DATE |
|---------------------|----|-----------------|----------|----------------|-------|---------------|----------------|
|                     | AA | 2003/0141504    | 07/31/03 | Kuwabara et al |       |               |                |
|                     | AB |                 |          |                |       |               |                |

## FOREIGN PATENT DOCUMENTS

|          |    | DOCUMENT<br>NO. | DATE       | COUNTRY | CLASS | SUB-<br>CLASS | TRANSLATION<br>YES NO PART. |  |    |
|----------|----|-----------------|------------|---------|-------|---------------|-----------------------------|--|----|
| /A.O.A./ | AC | 2003-152191     | 05/23/2003 | Japan   |       |               |                             |  |    |
| /A.O.A./ | AD | 2001-102442     | 04/13/2001 | Japan   |       |               |                             |  | xx |
| /A.O.A./ | AE | 2000-150664     | 05/30/2000 | Japan   |       |               |                             |  | xx |
| /A.O.A./ | AF | 10-209453       | 08/07/1998 | Japan   |       |               |                             |  | xx |
| /A.O.A./ | AG | 2004-349702     | 12/09/2004 | Japan   |       |               |                             |  | xx |
| /A.O.A./ | AH | 07-335735       | 12/22/1995 | Japan   |       |               |                             |  | xx |
| /A.O.A./ | AI | 05-021465       | 01/29/1993 | Japan   |       |               |                             |  | xx |

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

|   |    |   |
|---|----|---|
| /A.O.A./  | AJ | Sasaki et al, "Proposal of a Multi-Layer Channel MOSFET: the application of selective etching for Si/SiGe stacked layers," Applied Surface Science, Vol. 234, pp 270-273. |
|   | AK |   |
|   | AL |   |
| EXAMINER /Andrew O. Arena/  |    | DATE CONSIDERED 12/22/2008  |
| *EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. |    |   |